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Bib Data Sheet

CONFIRMATION NO. 3480

SERIAL NUMBER 09/856,823	FILING DATE 05/25/2001 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 0819-559
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** CONTINUING DATA *****

This application is a 371 of PCT/JP00/06851 10/03/2000 M>

** FOREIGN APPLICATIONS *****

JAPAN 11-282668 10/04/1999 M>

JAPAN 2000-263467 08/31/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/08/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Mach</i> Examiner's Signature	<i>M</i> Initials			

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TITLE

Method for fabricating semiconductor device

☐ All Fees